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PATENT APPLICATION  
Docket No. 11675.107

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

David Y. Kao et al.

Serial No.:

08/720,693

Filed:

October 2, 1996

For:

OXIDATION OF ION IMPLANTED  
SEMICONDUCTORS

Examiner:

George Fourson III

) Art Unit  
) 2823RECEIVED  
SEP 19 2002  
TECHNOLOGY CENTER 2800AMENDMENT AND RESPONSEBox RCE  
Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed from the United States Patent and Trademark Office on April 12, 2002, please enter the following amendments and remarks into the file of the above-identified application.

IN THE CLAIMS:

Please cancel claims 6, 20, and 21.

Please amend the claims as follows: